DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

(X) Original	() Supplemental () Substitute	() PCT () DESIGN	
next to my name; that I verily believe	hereby declare that: my residence, pose that I am the original, first and sole tral inventors are named below) of the led:	inventor (if only one name is lis	ited below) or an
Title: METHOD FOR FORMING GA	AS CLUSTER AND METHOD FOR I	FORMING THIN FILM	
of which is described and claimed in: (X) the attached specification, or () the specification in the application and with amendments through () the specification in International A	Serial No filed (if applicable), or pplication No. PCT/ icable).		amended on
amended by any amendment(s) referr I acknowledge my duty to disclose inf	ormation of which I am aware which i	•	
of any foreign application(s) for pa	ts under Title 35, United States Code, tent or inventor's certificate listed be ertificate having a filing date before the	clow and have also identified b	clow any foreign
COUNTRY	Application no.	DATE OF FILING	PRIORITY CLAIMED
Japan	121983/1995	May 19, 1995	Yes
Japan	244957/1995	September 22, 1995	Yes
Jupan	064861/1996	March 21, 1996	Yes
as the subject matter of each of the cla provided by the first paragraph of Til	35. United States Code §120 of any United States Code §120 of any United States Code §112, 1 acknowled Regulations, §1.56(a) which occurrifiling date of this application:	in the prior United States applica nowledge the duty to disclose ma	tion in the manner iterial information
APPLICATION SERIAL NO.	U.S. FILING DATE	STATUS: PATENT ABANDO	
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And I hereby appoint V. M. Creedon, .ceg. No. 17,111; John T. Miller, Reg. No. 21,120; John T. Fedigan, Reg. No. 24,347; Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Jeffrey Nolton, Reg. No. 25,408; Warren M. Cheek, Jr., Reg. No. 33,367; and Adam C. Volentine, Reg. No. 33,289, who together constitute the firm of WENDEROTH, LIND & PONACK, jointly and severally, attorneys to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

I hereby authorize the U.S. attorneys named herein to accept and follow instructions from NISHIZAWA & ASSOCIATES as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

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I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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The above application may be more particularly identified as follows:

U.S. Application Scrial No.	Filing Date
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Applicant Reference Number 96-F-008US Any Docket No. 653/95F008US

Title of Invention METHOD FOR FORMING GAS CLUSTER AND METHOD FOR FORMING THIN FILM